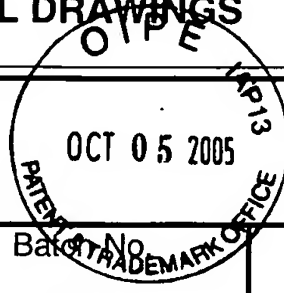


IPD

TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
FIS920030286US1

In Re Application Of: Michael P. Belyansky et al.



Serial No.

10/605,889

Filing Date

11/04/2003

Barcode No.

N/A

Examiner

Long Pham

Art Unit

2814

Invention:

OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

9 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

A handwritten signature in black ink, appearing to read "Jay H. Anderson", written over a horizontal line.

Signature

Dated: September 29, 2005

Jay H. Anderson
Registration No. 38,371
Telephone No. 845-894-3667
Fax No. 892-6363

I certify that this document and attached formal drawings are being deposited on September 29 2005 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence